

**IN THE CLAIMS:**

Please amend the claims as follows.

Claim 1 (Currently Amended): A pattern transfer apparatus for putting a transfer die having a concavo-convex pattern against a transfer target on a substrate to transfer the concavo-convex pattern onto a surface of said transfer target, wherein at least part of said transfer die is made of a ferromagnetic material; the pattern transfer apparatus comprising:

first pressing means for putting the transfer die onto the surface of said transfer target, said first pressing means ~~includes~~ including magnetic force generating means for generating a magnetic force~~[[;]]~~ ~~said magnetic force generating means are provided to near said substrate and~~ ~~comprises~~ and having at least two or more electromagnets which are provided to near said substrate; [[and]]

wherein said magnetic force generating means applies a magnetic force to said transfer die with said substrate interposed therebetween, thereby pressing said transfer die against said substrate,

the pattern transfer apparatus further comprising second pressing means for pressing said transfer die against a transfer target on said substrate uniformly, wherein said second pressing means includes: pressure applying means; and a balloon for transmitting a pressure of said pressure applying means to said transfer die.

Claims 2-3 (Canceled).

Claim 4 (Original): The pattern transfer apparatus according to claim 1, wherein said pressing means includes a current controller for adjusting the amounts of current to flow through said electromagnets, respectively.

Claim 5 (Original): The pattern transfer apparatus according to claim 4, comprising: measuring means for measuring a distance between said substrate and said transfer die in at least two or more measuring points; and control means for receiving signals on the measuring points and the measured distances from said measuring means, determining currents to be applied to said respective electromagnets so that the measured distances at the measuring points become a predetermined value, and transmitting a signal to said current controller.

Claim 6 (Currently Amended): The pattern transfer apparatus according to claim 1, wherein said magnetic force generating means further has at least two or more permanent magnets and ~~magnetic force adjustable means for changing magnetic forces to reach said transfer die from said permanent magnets~~ which are embedded in a flat plate above the transfer die and are thus incapable of applying a magnetic force to the die with the substrate interposed therebetween, wherein the flat plate is made of light-transmitting materials and not made of a ferromagnetic material.

Claim 7 (Currently Amended): The pattern transfer apparatus according to claim 6, wherein ~~said magnetic force adjustable means includes moving means for moving said permanent magnets~~ are placed so as to correspond to the positions of the electromagnets.

Claims 8-11 (Canceled).

Claim 12 (Currently Amended): The pattern transfer apparatus according to ~~any one of claims 5, 8, and 11~~ claim 5, wherein said measuring means is a distance measuring device using laser reflection.

Claim 13 (Currently Amended): The pattern transfer apparatus according to ~~any one of claims 5, 8, and 11~~ claim 5, wherein said measuring means is a distance measuring device using ultrasonic reflection.

Claim 14 (Currently Amended): The pattern transfer apparatus according to ~~any one of claims 5, 8, and 11~~ claim 5, wherein said measuring means is a distance measuring device using a change in capacitance.

Claims 15-16 (Canceled).

Claim 17 (Withdrawn): A pattern transfer method for putting a transfer die having a concavo-convex pattern against a transfer target on a substrate to transfer said concavo-convex pattern onto a surface of said transfer target,

the method comprising:

a uniform pressure pressing step of pressing said transfer die against said transfer target on said substrate with uniform pressure; and

a nonuniform pressure pressing step of pressing said transfer die against said transfer target on said substrate at a plurality of different locations independently so that it is compensated to incline and distort said transfer die.

Claim 18 (Withdrawn): The pattern transfer method according to claim 17, comprising the step of arranging said transfer die in parallel with said substrate prior to the uniform pressure pressing step.

Claim 19 (Withdrawn): The pattern transfer method according to claim 17, wherein the nonuniform pressure pressing step includes the step of increasing a force for pressing said transfer die against said substrate, with an increasing distance between said substrate and said transfer die.

Claim 20 (Withdrawn): The pattern transfer method according to claim 17, wherein the nonuniform pressure pressing step includes the step of making a force for pressing a distorted area of said transfer die against said substrate greater than with other areas.

Claim 21 (Withdrawn): The pattern transfer method according to claim 17, wherein the nonuniform pressure pressing step includes the step of applying a force for pressing said transfer die against said substrate to only a distorted area of said transfer die.

Claim 22 (Withdrawn): The pattern transfer method according to claim 17, further comprising a measuring step of measuring a distance between said substrate and said transfer die

in at least two or more measuring points, and wherein the nonuniform pressure pressing step includes applying locally different pressing forces so that the distance measurements obtained from the measuring points in the measuring step become a predetermined value.